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## BIB DATA SHEET

CONFIRMATION NO. 5182

<b>SERIAL NUMBER</b> 10/072,415	<b>FILING or 371(c) DATE</b> 02/05/2002 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2891	<b>ATTORNEY DOCKET NO.</b> MI30-068		
<b>APPLICANTS</b> Ji Ung Lee, Cohoes, NY; John Lee, Meridian, ID; Benham Moradi, Boise, ID;						
<b>** CONTINUING DATA *****</b> This application is a CON of 09/260,231 03/01/1999 PAT 6,344,378 <i>SJF</i>						
<b>** FOREIGN APPLICATIONS *****</b> <i>None. SJF</i>						
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 04/12/2002						
Foreign Priority claimed <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No Verified and Acknowledged <u>/STEVEN J FULK/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance <i>SJF</i> Initials	<b>STATE OR COUNTRY</b> NY	<b>SHEETS DRAWINGS</b> 8	<b>TOTAL CLAIMS</b> 38	<b>INDEPENDENT CLAIMS</b> 8
<b>ADDRESS</b> WELLS ST. JOHN P.S. 601 W. FIRST AVENUE, SUITE 1300 SPOKANE, WA 99201 UNITED STATES						
<b>TITLE</b> Field effect transistor fabrication methods, field emission device fabrication methods, and field emission device operational methods						
<b>FILING FEE RECEIVED</b> 3034	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			